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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/875,619	06/06/2001	Michael J. Dixon	27754/21720	7775
4743	7590 04/20/2004	EXAMINER		
MARSHALL, GERSTEIN & BORUN LLP 6300 SEARS TOWER 233 S. WACKER DRIVE			LIANG, LEONARD S	
			ART UNIT	PAPER NUMBER
CHICAGO, II	CHICAGO, IL 60606			
			DATE MAILED: 04/20/2004	4

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)			
		09/875,619	DIXON ET AL.			
	Office Action Summary	Examiner	Art Unit			
		Leonard S Liang	2853			
Period fo	• •					
THE - Exte after - If the - If NO - Failu	ORTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. nsions of time may be available under the provisions of 37 CFR 1.1 SIX (6) MONTHS from the mailing date of this communication. e period for reply specified above is less than thirty (30) days, a reply period for reply is specified above, the maximum statutory period or the toreply within the set or extended period for reply will, by statute reply received by the Office later than three months after the mailing ed patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a y within the statutory minimum of thi will apply and will expire SIX (6) MOI or cause the application to become A	reply be timely filed  ty (30) days will be considered timely.  NTHS from the mailing date of this communication.  BANDONED (35 U.S.C. § 133).			
Status						
1)⊠	Responsive to communication(s) filed on 26 Ja					
2a) <u></u> ☐	☐ This action is <b>FINAL</b> . 2b) ☐ This action is non-final.					
3)	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits					
	closed in accordance with the practice under E	<u>=x paπe Quayie,</u> 1935 C.I	J. 11, 400 O.G. 218.			
Disposit	ion of Claims					
4)⊠	Claim(s) 1-7 and 35-37 is/are pending in the a					
	4a) Of the above claim(s) is/are withdra					
,	Claim(s) is/are allowed.					
	Claim(s) <u>1-7 and 35-37</u> is/are rejected.					
	Claim(s) is/are objected to.	t di company				
8)[	Claim(s) are subject to restriction and/o	or election requirement.				
Applicat	ion Papers					
9)🖾	The specification is objected to by the Examine	er.				
10)🖂	The drawing(s) filed on <u>01 June 2001</u> is/are: a	ı)∐ accepted or b)⊠ obj	ected to by the Examiner.			
	Applicant may not request that any objection to the	drawing(s) be held in abeya	ince. See 37 CFR 1.85(a).			
	Replacement drawing sheet(s) including the correct	tion is required if the drawin	g(s) is objected to. See 37 GFK 1.12 (d).			
11)[_]	The oath or declaration is objected to by the E	xaminer. Note the attache	ed Office Action of form F 10-132.			
Priority	under 35 U.S.C. § 119					
12)⊠	Acknowledgment is made of a claim for foreign	n priority under 35 U.S.C.	§ 119(a)-(d) or (f).			
	)⊠ All b)□ Some * c)□ None of:					
	1.⊠ Certified copies of the priority documen					
	2. Certified copies of the priority documen	ts have been received in	Application No			
	3. Copies of the certified copies of the price		n received in this National Stage			
	application from the International Burea		t reneived			
*	See the attached detailed Office action for a list	t of the certified copies no	or received.			
Attachme	nt(s)					
1) 🛛 Not	ice of References Cited (PTO-892)		Summary (PTO-413)			
2) 🔲 Not	ice of Draftsperson's Patent Drawing Review (PTO-948)	-, [T] <b>,</b> , ,, ,, ,	o(s)/Mail Date Informal Patent Application (PTO-152)			
	rmation Disclosure Statement(s) (PTO-1449 or PTO/SB/08 ler No(s)/Mail Date <u>08/04/01</u> .	6) Other: _				

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### **DETAILED ACTION**

#### Election/Restrictions

1. The applicant has elected Species I (Claims 1-7 and 35-37) with traverse. The applicant has proposed an alternative restriction/election requirement selecting a proposed Group I, which includes claim 1-13 and 35-37. However, upon examination of the claims, the examiner maintains the election of Species I (Claims 1-7, and 35-37). The reason for this is because claims 8-13 seem to represent a different species from claims 1-7. One of the key concepts in claims 1-7 is the concept of the resistance to flow of the inlet and outlet manifolds, and this concept is absent from claims 8-13. Furthermore, the applicant has argued that the previous election/restriction requirement was unclear, but did not specify how it was unclear. The restriction requirement is thus made final and claims 1-7 and 35-37 will herein be prosecuted.

### Specification and Drawings

2. The lengthy specification and drawings have not been checked to the extent necessary to determine the presence of all possible minor errors. Applicant's cooperation is requested in correcting any errors of which applicant may become aware in the specification and drawings.

### Claim Objections

3. Claims 1 and 4 are objected to because of the following informalities: Claim 1 states "means for generating a fluid flow into said inlet manifold, though each chamber is said array..."

This doesn't make sense. It will be construed that the claim should state "means for generating a

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fluid flow into said fluid manifold, through each chamber in said array..." Claim 4 requires a similar correction. Appropriate correction is required.

# Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

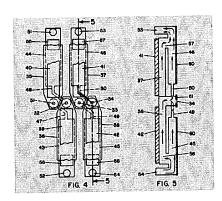
- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claims 1-4, 6-7, 36-37 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hoisington et al (US Pat 4835554) in view of Zhang (EP Pat 0810093 A2).

## Hoisington et al discloses:

- {claims 1 and 4} Droplet deposition apparatus comprising: an array of fluid chambers, each chamber communicating with an orifice for droplet ejection, a common fluid inlet manifold and a common fluid outlet manifold (figure 4-5, reference 34, 53-54); and means for generating a fluid flow into the inlet manifold through each chamber in the array and into the outlet manifold, the fluid flow through each chamber being sufficient to prevent foreign bodies in the fluid from lodging in the orifice (figure 5, reference 53-54; column 5, lines 15-29; abstract); wherein each chamber is associated with means for effecting droplet ejection from the orifice simultaneously with the fluid flow through the chamber (column 4, line 59-column 5, line 68)
- {claims 6 and 36} the array of chambers is linear (figures 4-5)

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• {claims 7 and 37} the array is angled to the horizontal and the inlet manifold extends parallel to the array, the properties of the inlet manifold varying in a direction lying parallel to the array in such a way as to substantially match the rate of pressure loss along the inlet manifold due to viscous losses in the inlet manifold to the rate of increase of static pressure along the inlet manifold due to gravity (figure 4-5; column 3-6)



Hoisington et al differs from the claimed invention in that it does not disclose:

- {claim 1} the resistance to flow of the inlet and outlet manifolds is chosen such that the static pressure at the orifice of any chamber in the array due to the flow varies between any two chambers by an amount less than that which would give rise to significant differences in droplet ejection properties between the two chambers in the array
- {claim 2} the inlet manifold has a resistance to flow less than that which would give rise to a variation in static pressure between the inlets to any two chambers in the array sufficient to produce significant differences in droplet ejection properties between the two chambers in the array

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- {claim 3} the resistance to flow of the outlet manifold is chosen such that the pressure at a fluid inlet to any chamber in the array varies between any two chambers by an amount less than that which would give rise to significant differences in droplet ejection properties between the two chambers in the array
- {claim 4} the resistance to flow of one of the inlet and outlet manifolds being chosen such that the pressure at a fluid inlet to any chamber in the array varies between any two chambers by an amount less than that which would give rise to significant differences in droplet ejection properties between the two chambers in the array

### Zhang discloses:

- {claim 1} the resistance to flow of the inlet and outlet manifolds is chosen such that the static pressure at the orifice of any chamber in the array due to the flow varies between any two chambers by an amount less than that which would give rise to significant differences in droplet ejection properties between the two chambers in the array (column 9, line 46-column 11, line 58)
- {claim 2} the inlet manifold has a resistance to flow less than that which would give rise to a variation in static pressure between the inlets to any two chambers in the array sufficient to produce significant differences in droplet ejection properties between the two chambers in the array (column 9, line 46-column 11, line 58)
- {claim 3} the resistance to flow of the outlet manifold is chosen such that the pressure at a fluid inlet to any chamber in the array varies between any two chambers by an amount less than that which would give rise to significant

differences in droplet ejection properties between the two chambers in the array (column 9, line 46-column 11, line 58)

• {claim 4} the resistance to flow of one of the inlet and outlet manifolds being chosen such that the pressure at a fluid inlet to any chamber in the array varies between any two chambers by an amount less than that which would give rise to significant differences in droplet ejection properties between the two chambers in the array (column 9, line 46-column 11, line 58)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teachings of Zhang into the invention of Hoisington et al. The motivation for the skilled artisan in doing so is to gain the benefit of providing uniform ink flow to the ink chambers, so that ink droplets can be jetted stably and effectively (column 9, line 46-column 12, line 8).

5. Claims 5 and 35 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hoisington et al (US Pat 4835554) in view of Zhang (EP Pat 0810093 A2), as applied to claims 1 and 4 above, and further in view of Burr et al (EP Pat 0622210 A1).

Hoisington et al, as modified, teaches all limitations of the claimed invention except for the following: the cross-sectional area of at least one of the inlet and outlet manifolds is such that the pressure varies between any two chambers by an amount less than that which would give rise to significant differences in droplet ejection properties between the two chambers in the array.

Burr et al discloses, with respect to claims 5 and 35, the cross-sectional area of at least one of the inlet and outlet manifolds is such that the pressure varies between any two chambers

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by an amount less than that which would give rise to significant differences in droplet ejection properties between the two chambers in the array (abstract; page 11, lines 22-25).

It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teachings of Burr et al into the invention of modified Hoisington et al. The motivation for the skilled artisan in doing so is to gain the benefit of producing uniform flow rates and avoiding significant pressure loss in order to ensure effective ink ejection (abstract; page 11, lines 22-25).

#### Conclusion

6. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Rezanka (US Pat 5818485) discloses a thermal ink jet printing system with continuous ink circulation through a printhead.

Hagiwara et al (US Pat 6039442) discloses an electrostatic ink jet recording device having a stirring system.

Piatt et al (US Pat 4734711) discloses a pressure regulation system for multi-head ink jet printing apparatus.

Roy et al (US Pat 5087930) discloses a drop-on-demand ink jet print head.

Field et al (US Pat 5969736) discloses a passive pressure regulator for setting the pressure of a liquid to a predetermined pressure differential below a reference pressure.

Pennebaker, Jr. et al (US Pat 4011157) discloses ultrasonic removal of solid impurities from recirculating ink.

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Takita (US Pat 5097275) discloses an ink jet printer head.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Leonard S Liang whose telephone number is (703) 305-4754. The examiner can normally be reached on 8:30-5 Monday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Stephen Meier can be reached on (703) 308-4896. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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